

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Osamu Goto, et al.

Application No. 10/606,176

Filed: June 25, 2003

For: SEMICONDUCTOR LIGHT EMITTING
DEVICE, ITS MANUFACTURING METHOD,
SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD

Group Art Unit: 2811

Examiner: Ori Nadav

I hereby certify that this document is being deposited
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AMENDMENT, Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450 on October 21,
2005.


Roxanne M. Swartz

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO JUNE 23, 2005 OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Office Action mailed June 23, 2005.
Applicants respectfully request amendment of the patent application, and reconsideration and
allowance of the pending claims.